



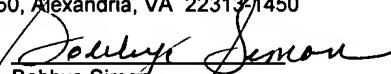
03-06-06 TIED 1732

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/521,635
Applicant : K. Tommy Haraldsson
Filed : October 26, 2005
TC/A.U. : 1732
Examiner : Not assigned
For : "Fabrication of 3D Photopolymeric Devices
Docket No. : 72-03
Customer No.: 23713

Confirmation No. 2635

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Commissioner for Patents
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Alexandria, VA 22313-1450

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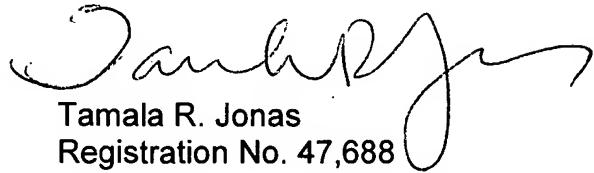
Sir:

The Examiner is respectfully requested to consider the references, copies enclosed, which may qualify as prior art. For the Examiner's convenience, the references are listed on the attached substitute for Patent and Trademark Office form PTO-1449. Pursuant to 37 C.F.R. 1.98(a)(2)(ii), copies of cited U.S. patents and U.S. patent application publications are not included, but will be provided upon request.

This information is cited in a spirit of forthrightness and cooperation to enable the applicants to obtain that measure of protection for the invention to which there is entitlement. However, no representation is made that the listed art actually qualifies as prior art under the patent statute and the mere use of PTO-1449 is not an admission that all listed references are prior art. No representation is made that applicants know of the best art.

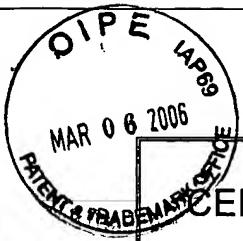
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Respectfully submitted,



Tamala R. Jonas
Registration No. 47,688

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Attorney Docket No. 72-03
TRJ:bds:March 3, 2006



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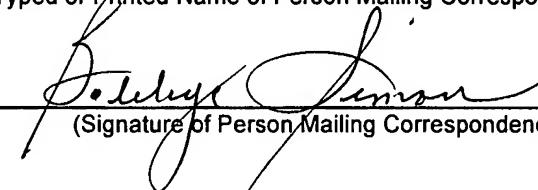
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Sheet 1 of 3

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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|------------------------|--------------|
| Application Number | 10/521,635 |
| Filing Date | 10/26/2005 |
| First Named Inventor | Haraldsson |
| Art Unit | 1732 |
| Examiner Name | Not assigned |
| Attorney Docket Number | 72-03 |

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U.S. PATENT DOCUMENTS

| Examiner Initial* | Cite No. ¹ | Document Number (US-) | Publication Date (MM-DD-YYYY) | Name | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear (or entire document unless noted otherwise) |
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|-------------------|-----------------------|---|-------------------------------|------|---|----------------|
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NON-PATENT LITERATURE DOCUMENTS

| Examiner Initial* | Cite No. ¹ | REFERENCE Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
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| Examiner Signature | Date Considered |
|--------------------|-----------------|

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Sheet 2 of 3

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| Art Unit | 1732 |
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| Attorney Docket Number | 72-03 |

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|-------------------|-----------------------|--|----------------|
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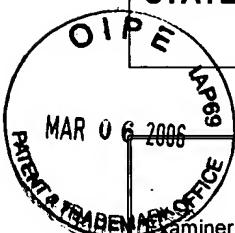
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